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PATENT

Docket No.: 4658-013

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jenn-Tsair TSAI

U.S. Patent Application No. 09/635,223

Filed: August 10, 2000

: Confirmation No. 6462

: Group Art Unit: 2626

: Examiner: WORKU, NEGUSSIE

For: METHOD FOR OPTIMIZING THE BEST RESOLUTION OF AN
OPTICAL SCANNING SYSTEM AND APPARATUS FOR THE SAME

AMENDMENT

RECEIVED

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAR 08 2004

Technology Center 2600

Sir:

In response to the Office action of December 5, 2003, please amend the
above-identified application as follows.